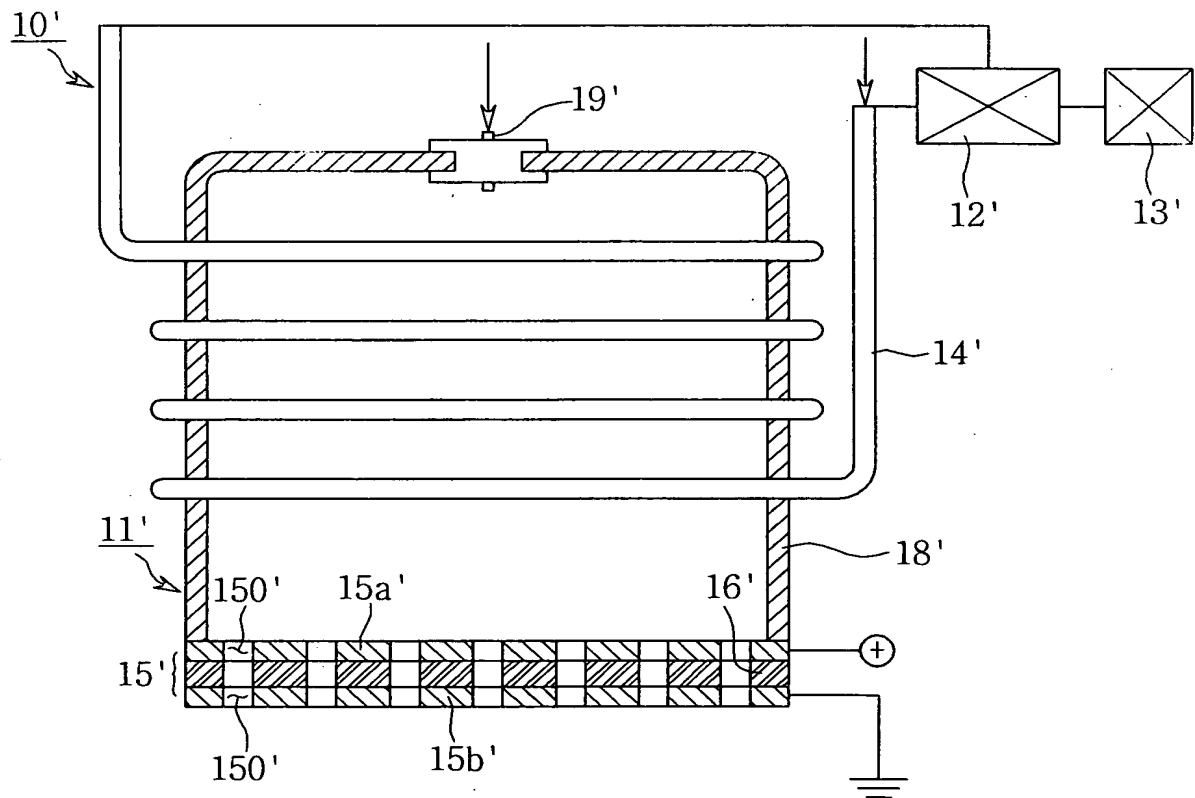


FIG. 1



Title: NEUTRAL BEAM SOURCE
HAVING ELECTROMAGNET USED
FOR ETCHING SEMICONDUCTOR
DEVICE

Inventor(s): Geun-Young YEOM et al.
DOCKET NO.: 061887-0120

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FIG. 2

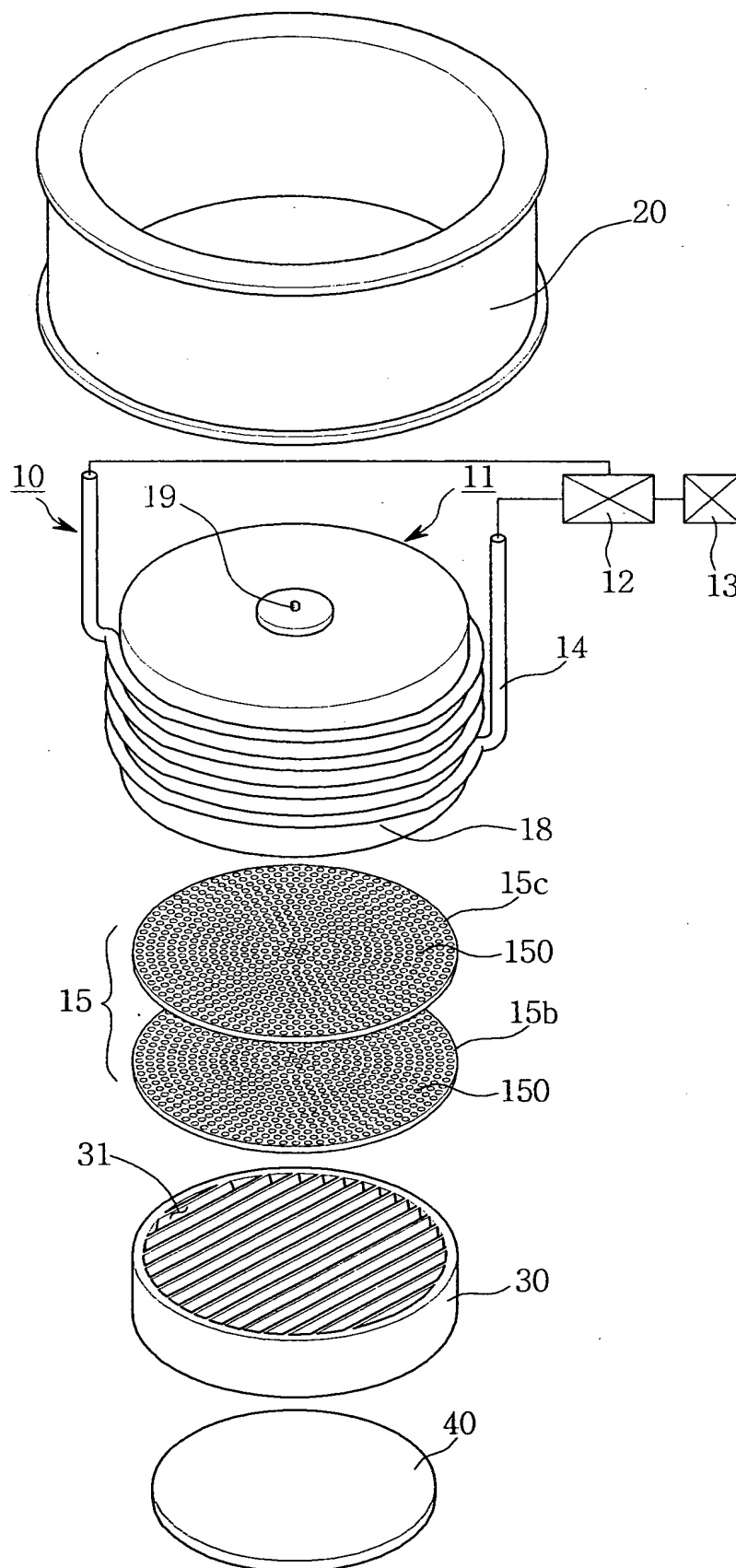


FIG. 3

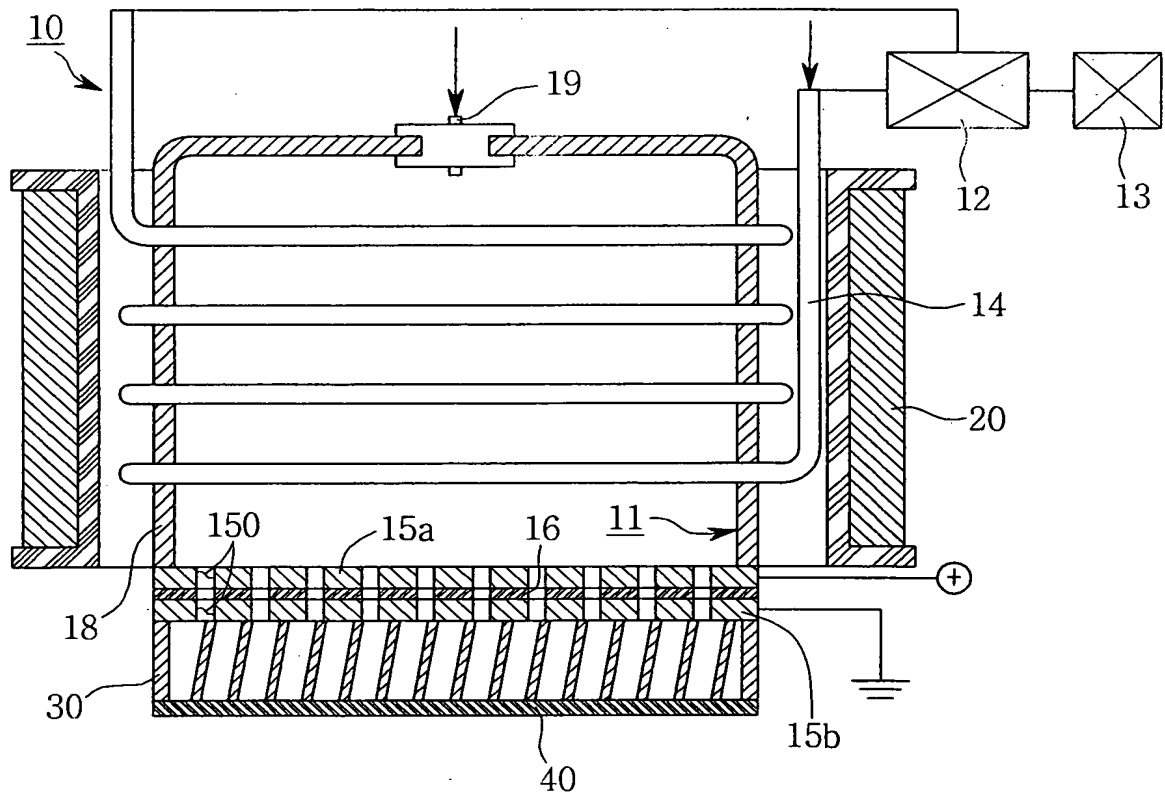


FIG. 4A

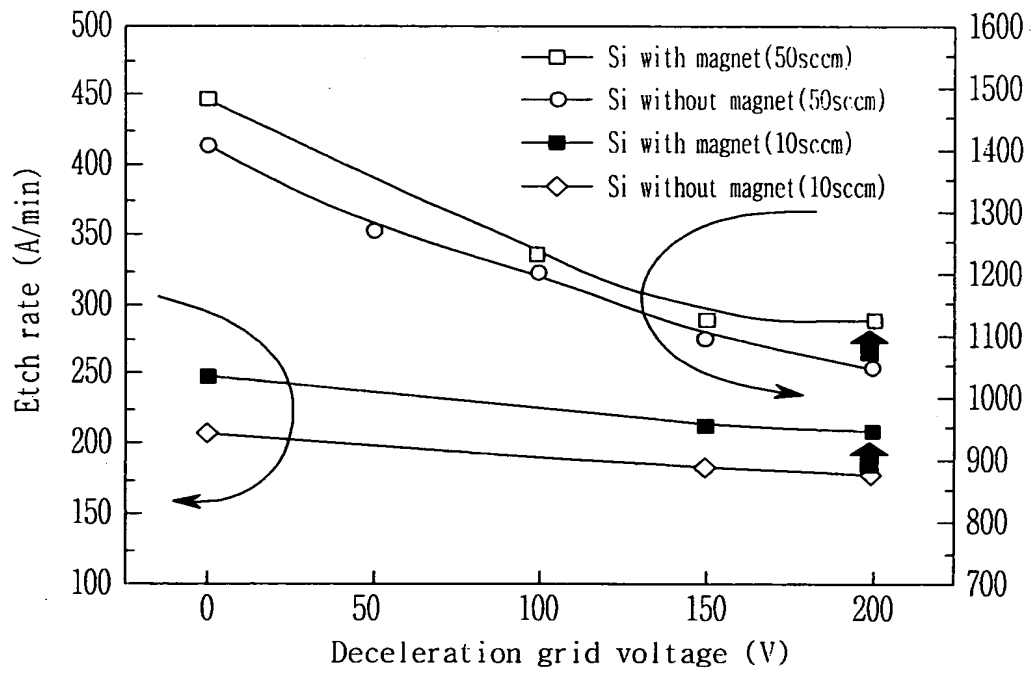


FIG. 4B

